

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)

**YKI-0145**

Application Number

Applicant(s)

**Ryuji Nishikawa**

Filing Date

Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
<i>ER</i>		JP 7-142170	1995.06.02	Japan				

**OTHER DOCUMENTS** (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

*Shounaga*

DATE CONSIDERED

*7/14/05*

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# INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

YKI-0145

Application Number

10/807,656

Applicant(s)

Ryuji Nishikawa

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03/24/2004

Group Art Unit

N/A

JUN 25 2004 U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SPR	1	6,410,168 B1	06/25/2002	Tamura			

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
SPR	1	2000-40591	08.02.2000	Japan				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

*Shoumang Hu*

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2/14/05

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